



PATENT
700623-3003

In The United States Patent and Trademark Office

In re Application of:

Assignee: Technologies and Devices
International, Inc.

Inventors: Yuri V. Melnik, *et al.*

App. No: 10/632,736

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Title: Reactor for Extended Duration Growth of
Gallium Containing Single Crystals

Docket: 700623-3003

Art Unit: 1763

Examiner: Moore, Karla A.

CERTIFICATE OF MAILING
UNDER 37 CFR § 1.8

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AMENDMENT

Mail Stop Amendment
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Alexandria, VA 22313-1450

Commissioner:

In response to non-final Office action mailed May 20, 2005, please amend the above-identified application as follows:

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